

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)
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10/529.333

Applicant

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Group Art Unit
1793

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
/CMK/	06-120022	04/28/94	JP			Abstract	
/CMK/	08-169756	07/02/96	JP			Abstract	
/CMK/	10-074612	03/17/98	JP			Abstract	
/CMK/	05-070219	03/23/93	JP			Abstract	
/CMK/	07-315919	12/05/95	JP			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

/C. Melissa Koslow/

DATE CONSIDERED

03/14/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.